

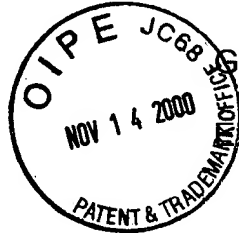
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of

Ki-sang KIM et al.

Serial No.: 09/237,229

Filed: January 26, 1999



Group Art Unit: 1763

Examiner: S. MacArthur

#100
11/16/00
MW

For: MULTI-CHAMBER SYSTEM HAVING COMPACT INSTALLATION SET-UP FOR
AN ETCHING FACILITY FOR SEMICONDUCTOR DEVICE MANUFACTURING

AMENDMENT

Honorable Assistant Commission of Patents and Trademarks,
Washington, D.C. 20231

Date: November 14, 2000

Sir:

In response to the Office Action dated August 14, 2000, the following
amendments and remarks are respectfully submitted.

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NOV 15 2000
1700 MAIL ROOM

In the Claims:

Please cancel claims 33-68 without prejudice or disclaimer of the subject matter
contained therein.

REMARKS

Claims 1-32 are pending in the present application. Claims 33-68 have been
canceled as being directed to a constructively non-elected invention. Applicants
respectfully reserve the right to file a Divisional Application including non-elected claims